

TRADEMARK ASSIGNMENT

Electronic Version v1.1
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT		
NATURE OF CONVEYANCE:	RELEASE BY SECURED PARTY		
CONVEYING PARTY DATA			
Name	Formerly	Execution Date	Entity Type
COMERICA BANK		05/31/2012	Texas banking association: TEXAS
RECEIVING PARTY DATA			
Name:	SUNIVA, INC.		
Street Address:	5775 Peachtree Industrial Boulevard		
City:	Norcross		
State/Country:	GEORGIA		
Postal Code:	30092		
Entity Type:	CORPORATION: DELAWARE		
PROPERTY NUMBERS Total: 9			
Property Type	Number	Word Mark	
Serial Number:	85041752	SUNIVA	
Serial Number:	85027584	THE BRILLIANCE OF SOLAR MADE SENSIBLE	
Serial Number:	85128307	OPTIMUS	
Serial Number:	77856093	ARTISUN OPTIMUS	
Serial Number:	77897955	POWERED BY SUNIVA	
Registration Number:	3679110	SUNIVA	
Registration Number:	3652250	ARTISUN	
Registration Number:	3599460	SUNIVA	
Serial Number:	85035220	SOLARITY	
CORRESPONDENCE DATA			
Fax Number:	8585506420		
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent via US Mail.</i>			
Phone:	858-550-6403		

CH \$240.00 85041752

Email: erin.obrien@cooley.com
Correspondent Name: Erin O'Brien
Address Line 1: c/o Cooley LLP
Address Line 2: 4401 Eastgate Mall
Address Line 4: San Diego, CALIFORNIA 92121

ATTORNEY DOCKET NUMBER:	036703-1181 SUNIVA
NAME OF SUBMITTER:	Erin O'Brien
Signature:	/Erin O'Brien/
Date:	05/31/2012

Total Attachments: 10

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RELEASE OF SECURITY INTEREST

This Release of Security Interest is made as of May 30, 2012 by COMERICA BANK ("Bank") in favor of Suniva, Inc., a Delaware Corporation, with its principal place of business at 5775 Peachtree Industrial Boulevard, Norcross, GA 30092 ("Company").

Recital

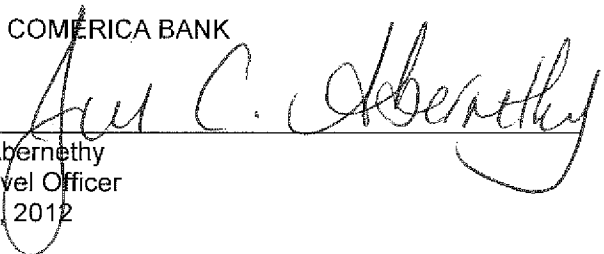
WHEREAS, COMPANY assigned certain interests in the copyrights, patents and trademarks described on Exhibits A, B and C and attached hereto, respectively (collectively, the "Intellectual Property") to BANK under an Intellectual Property Security Agreement dated as of November 10, 2010, and recorded with the US Patent and Trademark Office as set forth on Exhibits B and C.

WHEREAS, COMPANY has satisfied all its obligations to BANK in the Intellectual Property Security Agreement, and BANK wishes to release its security interest in the Intellectual Property.

Agreement

Now Therefore, BANK agrees that it terminates and releases its security interest in the Intellectual Property and reassigns to COMPANY, without warranty or recourse, all interest of BANK in the Intellectual Property.

BANK: COMERICA BANK



Jill C. Abernethy
First Level Officer
May 30, 2012

Address:
Comerica Bank
CLS Collateral Services, MC 7575
39200 Six Mile Road
Livonia, MI 48152

EXHIBIT A
COPYRIGHTS

<u>Description</u>	<u>Registration Number</u>	<u>Registration Date</u>
NONE		

EXHIBIT B

PATENTS

Assignee Name	Title	Patent/Application No.
Suniva	STRUCTURE AND FABRICATION PROCESS FOR AN ALUMINUM ALLOY JUNCTION SELF-ALIGNED BACK CONTACT SILICON SOLAR CELL	5641362
Suniva	METHOD FOR REMOVING COMPLEX OXIDE FILM, GROWTH ON SILICON CRYSTAL	5913980
Suniva	STRUCTURE AND FABRICATION PROCESS FOR SELF-ALIGNED LOCALLY DEEP-DIFFUSED EMITTER (SALDE) SOLAR CELL	5928438
Suniva	METHOD AND APPARATUS FOR SELF-DOPING NEGATIVE AND POSITIVE ELECTRODES FOR SILICON SOLAR CELLS AND OTHER DEVICES	6180869
Suniva	ALUMINUM ALLOY BACK JUNCTION SOLAR CELL AND A PROCESS FOR FABRICATION THEREOF	6262359
Suniva	METHOD FOR SELF-DOPING CONTACTS TO A SEMICONDUCTOR	6632730
Suniva	APPARATU FOR SELF-DOPING CONTACT TO A SEMICONDUCTOR	6664631
Suniva	METHOD AND APPARATUS FOR SELF-DOPING CONTACTS TO A SEMICONDUCTOR	6703295
Suniva	METHOD AND APPARATUS FOR SELF-DOPING CONTACTS TO A SEMICONDUCTOR	6737340
Suniva, Inc.	SOLAR CELL HAVING CRYSTALLINE SILICON P-N HOMOJUNCTION AND AMORPHOUS SILICON HETEROJUNCTIONS FOR SURFACE PASSIVATION	12036766 Publication #20090211627 Published 8/27/2009
Suniva, Inc.	METHOD FOR MAKING SOLAR CELL HAVING CRYSTALLINE	12036829 Publication

EXHIBIT B CONTINUED

PATENTS

	SILICON P-N HOMOJUNCTION AND AMORPHOUS SILICON HETEROJUNCTIONS FOR SURFACE PASSIVATION	#20090215218 Published 8/27/2009
Suniva, Inc.	SOLAR MODULE WITH SOLAR CELL HAVING CRYSTALLINE SILICON P-N HOMOJUNCTION AND AMORPHOUS SILICON HETEROJUNCTIONS FOR SURFACE PASSIVATION	12036839 Publication #20090211623 Published 8/27/2009

Bank's security interest recorded at the US Patent and Trademark Office on 11/19/2010 at Reel and Frame Number 0254/0616.

Exhibit B

Patents

Continued

Ebara-Originated Applications and Patents

A+B Ref	Title	Country	Application Number	Appl'n Date	Patent Number	Status
370567	Structure And Fabrication Process For An Aluminum Alloy Junction Self-Aligned Back Contact Silicon Solar Cell	USA	08/561,761	11/22/95	5641362	Patent granted June 24, 1997
371066	Structure And Fabrication Process For An Aluminum Alloy Junction Self-Aligned Back Contact Silicon Solar Cell	Australia	1996/3030	11/06/96	717476	Patent granted July 13, 2000
371068	Structure And Fabrication Process For An Aluminum Alloy Junction Self-Aligned Back Contact Silicon Solar Cell	Canada	2181281	07/16/96	2181281	Patent granted May 10, 2005
371067	Structure And Fabrication Process For Aluminum Alloy Junction Self-Aligned Back Contact Silicon Solar Cell	China	CN1998114483	11/15/96	1155106	Patent granted June 23, 2004
371066	Structure And Fabrication Process For An Aluminum Alloy Self-Aligned Back Contact Silicon Solar Cell	Germany	96395261.8	07/17/96	0776051	Patent granted March 10, 2004
371069	A Back Contact Solar Cell And A Method Of Manufacturing The Same	India	1317/MAS/1996	07/25/96	207254	Patent granted June 1, 2007
371070	Structure And Fabrication Process For An Aluminum Alloy Junction Self-Aligned Back Contact Silicon Solar Cell	Mexico	1996003169	06/01/98	197384	Patent granted July 5, 2000
370552	Method For Removing Complex Oxide Film Growth On Silicon Crystal	USA	08/831,808	04/10/97	5913960	Abandoned
371081	Structure And Fabrication Process For Self-Aligned Locally Deep-Diffused Emmitter (SALDE) Solar Cell	USA	08/726,279	10/04/96	5928438	Patent granted July 27, 1999
371071	Self-Aligned Locally Deep-Diffused Emmitter Solar Cell	Australia	1996/2039	10/01/96	7011213	Patent granted May 6, 1999
371072	Structure And Fabrication Process For Self-Aligned Locally Deep-Diffused Emmitter (SALDE) Solar Cell	Brazil	BR19960010738	10/01/96	PI9610738-1	Patent granted April 30, 2002
371073	Structure And Fabrication Process For Self-Aligned Locally Deep-Diffused Emmitter (SALDE) Solar Cell	Canada	2232857	10/01/96	2232857	Patent granted May 13, 2003
371074	Self-Aligned Locally Deep-Diffused Emmitter Solar Cell And Producing Method Thereof	China	ZL19961097446	10/01/96	1155107	Patent granted June 23, 2004
371080	A Solar Cell And A Method Of Fabricating The Same	India	1784/MAS/1996	10/07/96	186901	Patent granted February 21, 2006
371079	Self-Aligned Locally Deep-Diffused Emmitter	Mexico	19982174	10/01/96	204413	Patent granted September 28, 2001

371088	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	USA	09/072,411	05/04/98	6180888	Patent granted January 30, 2001
371082	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	Australia	200218038	05/05/98	798033	Patent granted January 22, 2004
371084	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	Brazil	P119980009237	05/05/98		Abandoned
371085	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	Canada	2287834	05/05/98	2287834	Patent granted July 5, 2005
371080	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	China	CN10988008900	05/05/98	1230920	Patent granted December 7, 2005
371086	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	EPG	98920273.4	05/05/98		Abandoned
371087	A Method Of Manufacturing A Solar Cell And A Solar Cell	India	984/MAS/1998	05/04/98	208319	Patent granted July 29, 2007
371089	Method And Apparatus For Self-Doping Negative And Positive Electrodes For Silicon Solar Cells And Other Devices	Mexico	198010119	05/05/98	238564	Patent granted August 16, 2006
Original Filings						
371093	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	USA	09/414,980	10/07/99	6262359	Patent granted July 17, 2001
371092	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	Australia	200047955	02/01/00	772413	Patent granted August 12, 2004
371094	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	Brazil	P120000008085	02/01/00		Pending
371098	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	Canada	2368039	02/01/00	2368039	Patent granted May 2, 2006
371099	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	China	CN20008008889	02/01/00	1179421	Patent granted December 8, 2004
371100	A Solar Cell And A Process For Fabricating A Solar Cell	India	IN/PCT/2001/1287/CHE	02/01/00	221312	Patent granted June 20, 2006
371101	Aluminum Alloy Back Junction Solar Cell And A Process For Fabrication Thereof	Mexico	20019280	02/01/00	234867	Patent granted March 17, 2008

371105	Method For Self-Doping Contacts To A Semiconductor	USA	08/638,034	03/29/00	6832730	Patent granted October 14, 2003
371102	Method And Apparatus For Self-Doping Contacts To A Semiconductor	Australia	200117983	11/22/00	780980	Patent granted August 11, 2005
371103	Method And Apparatus For Self-Doping Contacts To A Semiconductor	Brazil	BR20000015803	11/22/00		Abandoned
371107	Method And Apparatus For Self-Doping Contacts To A Semiconductor	Canada	2392342	11/22/00	2392342	Patent granted June 7, 2001
371108	Method And Apparatus For Self-Doping Contacts To A Semiconductor	China	CN20008017914	11/22/00	1280830	Patent granted June 21, 2006
371109	Method And Apparatus For Self-Doping Contacts To A Semiconductor	EPC	880763.7	11/22/00		Abandoned
371111	A Method Of Manufacturing A Semiconductor Device	India	IN/PCT/2000/783/CHE	11/22/00	202448	Patent granted October 3, 2006
371113	Method And Apparatus For Self-Doping Contacts To A Semiconductor	USA	10/176,451	06/19/02	6737340	Patent granted May 18, 2004
371108	Apparatus For Self-Doping Contacts To A Semiconductor	USA	10/177,880	06/20/02	6864831	Patent granted December 15, 2003
371110	Method And Apparatus For Self-Doping Contacts To A Semiconductor	USA	10/405,298	04/01/03	6703295	Patent granted March 9, 2004

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Suniva-Originated Applications and Patents

A+B Ref	Title	Country	Application Number	Appl'n Date	Patent Number	Status
ALPHA-STAR						
338576	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	USA	12036,766	02/25/08		Application submitted and in patent office review
344794	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	PCT	PCT/US2008/007356	06/11/08		National phase applications filed August 2010
344798	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Taiwan	97124397	06/11/08		Published September 1, 2009; first office action not yet received
371828	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Europe	8779639.3	06/11/08		Application filed June 11, 2008
380480	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Europe	8175495.2	06/11/08		Application filed June 11, 2008
371831	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Japan	N/A	06/11/08		Application filed June 11, 2008
394786	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Brazil	N/A	08/20/10		Application filed August 20, 2010
394787	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Canada	N/A	08/25/10		Application filed August 25, 2010
394788	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	China	N/A	08/20/10		Application filed August 20, 2010
394819	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Mexico	MX/A/2010/009957	08/25/10		Application filed August 25, 2010
394850	Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	India	N/A	08/28/10		Application filed August 28, 2010
ALPHA-STAR						
338584	Method For Making Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	USA	12038,829	02/25/08		Published August 27, 2009; first office action not yet received
344795	Method For Making Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	PCT	PCT/US2008/007355	06/11/08		National phase applications filed August 2010
345279	Method For Making Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation In A Furnace Having Doped Sources	PCT	PCT/US2008/007358	06/11/08		National phase applications filed August 2010
344797	Method For Making Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Taiwan	97124399	06/11/08		Published September 1, 2009; first office action not yet received
345280	Method For Making Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation In A Furnace Having Doped Sources	Taiwan	97124422	06/11/08		Published September 1, 2009; first office action not yet received
394831	Method For Making Solar Cells Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation In A Furnace Having Doped Sources	India	8229/Del/NP/2010	08/27/10		Application filed August 27, 2010
394832	Method For Making Solar Cells Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation In A Furnace Having Doped Sources	EP	N/A	08/28/10		Application filed August 28, 2010
ALPHA-STAR						

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341210	Solar Module With Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	USA	12/03/08	02/25/08	Application submitted and under patent office review
344811	Solar Module With Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	PCT	PCT/US2008/007253	03/11/08	National phase applications filed August 2010
344812	Solar Module With Solar Cell Having Crystalline Silicon P-N Homojunction And Amorphous Silicon Heterojunctions For Surface Passivation	Taiwan	97124421		Published September 1, 2009; first Office Action not yet received
Inventor Disclosure 09-04					
371915	Solar Cells And Methods Of Fabrication Thereof	USA	12/201,808	02/28/10	Application filed February 8, 2010; Foreign filing due in 48 months.
Inventor Disclosure 09-08					
371920	Solar Cell Including Sputtered Reflective Layer And Method Of Manufacture Thereof	USA	12/684,682	01/08/10	Application filed January 8, 2010; Foreign filing due in 48 months.
Inventor Disclosure 09-11					
383240	Selective Emitter Solar Cells Formed By A Hybrid Diffusion And Ion Implantation Process	USA	12/793,334	06/03/10	Application filed June 3, 2010
Inventor Disclosure 09-10					
383245	Selective Front Surface Field Back Junction Solar Cell	USA			Application filed August 25, 2010
Inventor Disclosure 09-09					
383248	Ion Implanted Selective Emitter Solar Cells With In Situ Surface Passivation	USA	12/793,363	06/03/10	Application filed June 3, 2010

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EXHIBIT C
TRADEMARKS

Registrant	Trademark	Serial/Reg. No.
Suniva, Inc.	SUNIVA	85041752
Suniva, Inc.	THE BRILLIANCE OF SOLAR MADE SENSIBLE	85027584
Suniva, Inc.	OPTIMUS	85128307
Suniva, Inc.	ARTISUN OPTIMUS	77856093
Suniva, Inc.	POWERED BY SUNIVA	77897955
Suniva, Inc.	SUNIVA	3679110
Suniva, Inc.	ARTISUN	3652250
Suniva, Inc.	SUNIVA	3599460
Solarity, Inc.	SOLARITY	85035220

Bank's security interest recorded at the US Patent and Trademark Office on 11/19/2010 at Reel and Frame Number 4418/0980.